We claim:

- 1 1. A 4-DOF nonresonant micromachined gyroscope comprising:
- 2 a 2-DOF drive-mode oscillator; and
- a 2-DOF sense-mode oscillator, where the drive-mode oscillator and sense-
- 4 mode oscillators are mechanically decoupled and employ three interconnected proof
- 5 masses.
- 1 2. The 4-DOF nonresonant micromachined gyroscope of claim 1 wherein the 2-
- 2 DOF drive-mode oscillator and 2-DOF sense-mode oscillator utilize dynamical
- 3 amplification in the drive and sense directions to achieve large oscillation amplitudes
- 4 without resonance resulting in increased bandwidth and reduced sensitivity to structural
- 5 and thermal parameter fluctuations and damping changes.
- 1 3. The 4-DOF nonresonant micromachined gyroscope of claim 1 wherein one of the
- 2 three masses is an intermediate proof mass and another is a sensing element, and
- 3 wherein the 2-DOF drive-mode oscillator and 2-DOF sense-mode oscillator are
- 4 mechanically decoupled in the drive direction from the sense direction for robustness
- 5 and long-term stability and to allow the Coriolis force that excites the sensing element to
- 6 be generated by the intermediate proof mass with a larger mass, resulting in larger
- 7 Coriolis forces for increased sensor sensitivity so that control system requirements and
- 8 tight fabrication and packaging tolerances are relaxed, mode-matching is eliminated,

- and instability and zero-rate drift due to mechanical coupling between the drive and
 sense modes is minimized.
- The 4-DOF nonresonant micromachined gyroscope of claim 1 wherein the 2 DOF drive-mode oscillator and 2-DOF sense-mode oscillator include a drive means for
- 3 driving a mass in a drive direction and a sense means for sensing motion of a mass in a
- 4 sense direction, and wherein the three interconnected masses comprise a first, second
- 5 and third mass, the first mass being the only mass excited by the drive means,
- 6 oscillating in the drive direction and being constrained from movement in the sense
- 7 direction, the second and third masses being constrained from movement with respect
- 8 to each other in the drive direction and oscillating together in the drive direction but
- 9 oscillating independently from each other in the sense direction, the third mass being
- 10 fixed with respect to the second mass in the drive direction, but free to oscillate in the
- 11 sense direction, the first mass as a driven mass and the second and third masses
- 12 collectively as a passive mass comprising the drive-mode oscillator, the second and
- third masses comprising the sense-mode oscillator.
 - 1 5. The 4-DOF nonresonant micromachined gyroscope of claim 4 wherein the
- 2 second mass oscillates in the drive and sense directions to generate rotation-induced
- 3 Coriolis force that excites the 2-DOF sense-mode oscillator, a sense direction response
- 4 of the third mass, which comprises the vibration absorber of the 2-DOF sense-mode
- 5 oscillator, is detected for measuring the input angular rate.

- 1 6. The 4-DOF nonresonant micromachined gyroscope of claim 1 wherein the 2-
- 2 DOF drive-mode oscillator and 2-DOF sense-mode oscillator comprise a drive means
- 3 for driving a mass in a drive direction, a sense means for sensing motion of a mass in a
- 4 sense direction, and a substrate on which the drive-mode oscillator and sense-mode
- 5 oscillator are disposed, wherein the three interconnected masses comprise a first,
- 6 second and third mass, where the first mass is anchored to the substrate by a first
- 7 flexure which allows movement substantially only in the drive direction, where the
- 8 second mass is coupled to the first mass by a second flexure that allows movement in
- 9 the drive and the sense directions, and where the third mass is coupled to the second
- mass by a third flexure which allows movement substantially only in the sense direction.
 - 1 7. The 4-DOF nonresonant micromachined gyroscope of claim 6 wherein the first,
- 2 and third flexures are folded micromachined springs having a resiliency substantially in
- 3 only one direction and wherein the second flexure is comprised of two coupled folded
- 4 micromachined springs, each having a resiliency substantially in only one of two
- 5 different directions.
- 1 8. The 4-DOF nonresonant micromachined gyroscope of claim 1 wherein the 2-
- 2 DOF drive-mode oscillator and 2-DOF sense-mode oscillator each have two resonant
- 3 peaks and a flat region between the peaks, the gyroscope being operated in the flat
- 4 regions of the drive and sense-mode oscillators.

- 1 9. The 4-DOF nonresonant micromachined gyroscope of claim 8 wherein the 2-
- 2 DOF drive-mode oscillator and 2-DOF sense-mode oscillator are arranged and
- 3 configured to have matching drive and sense direction anti-resonance frequencies.
- 1 10. The 4-DOF nonresonant micromachined gyroscope of claim 1 wherein the 2-
- 2 DOF drive-mode oscillator and 2-DOF sense-mode oscillator comprise a drive means
- 3 for driving a mass in a drive direction, and a sense means for sensing motion of a mass
- 4 in a sense direction, wherein the three interconnected masses comprise a first, second
- 5 and third mass and coupled flexures, the second and the third masses combining to
- 6 comprise a vibration absorber of the drive-mode oscillator, which vibration absorber
- 7 mechanically amplifies the oscillations of the first mass.
- 1 11. The 4-DOF nonresonant micromachined gyroscope of claim 10 wherein the first
- 2 mass is driven at a driving frequency, ω_{drive} , by means of a input force F_{d} , which driving
- 3 frequency, ω_{drive} , is matched with the resonant frequency of an isolated passive mass-
- 4 spring system comprised of the second and third masses and coupled flexures, which
- 5 passive mass-spring system moves to cancel out the input force F_d applied to the first
- 6 mass, so that maximum dynamic amplification is achieved.
- 1 12. The 4-DOF nonresonant micromachined gyroscope of claim 1 wherein the 2-
- 2 DOF drive-mode oscillator and 2-DOF sense-mode oscillator comprise a drive means
- 3 for driving a mass in a drive direction, and a sense means for sensing motion of a mass
- 4 in a sense direction, wherein the three interconnected masses comprise a first, second

- 5 and third mass and coupled flexures, where the third mass acts as the vibration
- 6 absorber in the sense-mode oscillator to achieve large sense direction oscillation
- 7 amplitudes due to mechanical amplification.
- 1 13. The 4-DOF nonresonant micromachined gyroscope of claim 12 wherein a
- 2 sinusoidal Coriolis force is applied to the second mass, and where the frequency of the
- 3 sinusoidal Coriolis force is matched with a resonant frequency of the isolated passive
- 4 mass-spring system of the third mass and its coupled flexures, so that the third mass
- 5 achieves maximum dynamic amplification.
- 1 14. The 4-DOF nonresonant micromachined gyroscope of claim 1 wherein the 2-
- 2 DOF drive-mode oscillator and 2-DOF sense-mode oscillator comprise a drive means
- 3 for driving a mass in a drive direction, and a sense means for sensing motion of a mass
- 4 in a sense direction, wherein the three interconnected masses comprise a first, second
- 5 and third mass and coupled flexures, wherein the frequency response of both the drive-
- 6 mode oscillator and sense-mode oscillator have two resonant peaks and a flat region
- 7 between the peaks, wherein both of the drive-mode oscillator and sense-mode oscillator
- 8 are operated in the flat region of their response curves, and where the drive anti-
- 9 resonance frequency, ω_{2x} , of the second mass and sense anti-resonance frequency,
- 10 ω_{3y} , of the third mass are matched, namely where $\omega_{3y} = \omega_{2x}$, or equivalently $(k_{3v}/m_3)^{1/2} =$
- 11 $(k_{2x}/(m_2 + m_3))^{1/2}$ determines the optimal system parameters, together with the optimized
- 12 ratios $\mu_x = (m_2 + m_3)/m_1$, $\gamma_x = \omega_{2x}/\omega_{1x}$, $\mu_y = m_3/m_2$, and $\gamma_y = \omega_{3y}/\omega_{2y}$, where k_{3y} is the
- spring constant of the flexures coupled to the third mass, where m₃ is the magnitude of

- 14 the third mass, k_{2x} is the spring constant of the flexures coupled to the second mass, m₂
- is the magnitude of the second mass, m_3 is the magnitude of the third mass, ω_{1x} is the
- drive anti-resonance frequency of the first mass, and ω_{2y} is the sense anti-resonance
- 17 frequency of the second mass.
- 1 15. A method of operating a 4-DOF nonresonant micromachined gyroscope
- 2 comprising:
- driving a 2-DOF drive-mode oscillator with an applied force;
- 4 driving a 2-DOF sense-mode oscillator with a Coriolis force derived from the 2-
- 5 DOF drive-mode oscillator; and
- 6 mechanically decoupling the drive-mode oscillator and sense-mode oscillators.
- 1 16. The method of claim 15 wherein driving the 2-DOF drive-mode oscillator and
- 2 driving the 2-DOF sense-mode oscillator dynamical amplifies motion in the drive and
- 3 sense directions to achieve large oscillation amplitudes without resonance to result in
- 4 increased bandwidth and reduced sensitivity to structural and thermal parameter
- 5 fluctuations and damping changes.
- 1 17. The method of claim 15 where mechanically decoupling the drive-mode oscillator
- 2 and sense-mode oscillators comprises mechanically decoupling the drive-mode
- 3 oscillator and sense-mode oscillators in the drive direction from the sense direction for
- 4 robustness and long-term stability and exciting a sense element in the sense-mode
- 5 oscillator by a Coriolis force generated by an intermediate proof mass employed in both

- 6 the drive-mode and sense mode oscillators, the intermediate proof mass being provided
- 7 with a larger mass than the sense element, resulting in larger Coriolis forces for
- 8 increased sensor sensitivity so that control system requirements and tight fabrication
- 9 and packaging tolerances are relaxed, mode-matching is eliminated, and instability and
- 10 zero-rate drift due to mechanical coupling between the drive and sense modes is
- 11 minimized.
 - 1 18. The method of claim 15 wherein driving the 2-DOF drive-mode oscillator and
- 2 driving the 2-DOF sense-mode oscillator comprises driving a mass in a drive direction
- 3 and sensing motion of a mass in a sense direction, and wherein the 2-DOF drive-mode
- 4 oscillator and the 2-DOF sense-mode oscillator comprise three interconnected masses
- 5 namely a first, second and third mass, exciting the first mass only by a drive means,
- 6 oscillating the first mass in the drive direction with a driving force and constraining
- 7 movement of the first mass in the sense direction, constraining movement of the second
- 8 and third masses with respect to each other in the drive direction, oscillating the second
- 9 and third masses together in the drive direction but oscillating the second and third
- masses independently from each other in the sense direction, the third mass being fixed
- with respect to the second mass in the drive direction, oscillating the third mass in the
- sense direction, the first mass as a driven mass and the second and third masses
- 13 collectively as a passive mass comprising the drive-mode oscillator, the second and
- third masses comprising the sense-mode oscillator.

- 1 19. The method of claim 18 wherein oscillating the second mass in the drive and
- 2 sense directions generates a rotation-induced Coriolis force that excites the 2-DOF
- 3 sense-mode oscillator, and detecting a sense direction response of the third mass,
- 4 which comprises the vibration absorber of the 2-DOF sense-mode oscillator, for
- 5 measuring the input angular rate.
- 1 20. The method of claim 15 wherein the 2-DOF drive-mode oscillator and 2-DOF
- 2 sense-mode oscillator comprise a drive means for driving a mass in a drive direction, a
- 3 sense means for sensing motion of a mass in a sense direction, and a substrate on
- 4 which the drive-mode oscillator and sense-mode oscillator are disposed, wherein the
- 5 three interconnected masses comprise a first, second and third mass, further
- 6 comprising anchoring the first mass to the substrate by a first flexure and moving the
- 7 first mass substantially only in the drive direction, moving the second mass coupled to
- 8 the first mass by a second flexure in the drive and the sense directions, and moving the
- 9 third mass coupled to the second mass by a third flexure substantially only in the sense
- 10 direction.
- 1 21. The method of claim 20 further comprising coupling the first, second and third
- 2 masses by the first and third flexures by providing folded micromachined springs having
- 3 a resiliency substantially in only one direction and by the second flexure which is
- 4 comprised of two coupled folded micromachined springs, each having a resiliency
- 5 substantially in only one of two different directions.

- 1 22. The method of claim 15 wherein driving the 2-DOF drive-mode oscillator and
- 2 driving 2-DOF sense-mode oscillator comprises operating the gyroscope in the flat
- 3 regions of the drive and sense-mode oscillators between two resonant peaks.
- 1 23. The method of claim 22 further comprising matching drive and sense direction
- 2 anti-resonance frequencies of the 2-DOF drive-mode oscillator and 2-DOF sense-mode
- 3 oscillator.
- 1 24. The method of claim 15 wherein the 2-DOF drive-mode oscillator and 2-DOF
- 2 sense-mode oscillator comprise a drive means for driving a mass in a drive direction,
- 3 and a sense means for sensing motion of a mass in a sense direction, wherein the three
- 4 interconnected masses comprise a first, second and third mass and coupled flexures.
- 5 the second and the third masses combining to comprise a vibration absorber of the
- 6 drive-mode oscillator, further comprising mechanically amplifying the oscillations of the
- 7 first mass by means of the vibration absorber.
- 1 25. The method of claim 24 further comprising driving the first mass at a driving
- frequency, ω_{drive} , by means of a input force F_{d} , matching the driving frequency, ω_{drive} ,
- 3 with the resonant frequency of an isolated passive mass-spring system comprised of
- 4 the second and third masses and coupled flexures, and moving the passive mass-
- 5 spring system to cancel out the input force F_d applied to the first mass, so that maximum
- 6 dynamic amplification is achieved.

- 1 26. The method of claim 15 wherein driving the 2-DOF drive-mode oscillator and
- 2 driving 2-DOF sense-mode oscillator comprise driving a mass in a drive direction, and
- 3 sensing motion of a mass in a sense direction, and mechanically amplifying sense
- 4 direction oscillation amplitudes with a third mass acting as the vibration absorber in the
- 5 sense-mode oscillator.
- 1 27. The method of claim 26 further comprising applying a sinusoidal Coriolis force to
- 2 a second mass, and matching the frequency of the sinusoidal Coriolis force with a
- 3 resonant frequency of an isolated passive mass-spring system of the third mass and its
- 4 coupled flexures, so that the third mass achieves maximum dynamic amplification.
- 1 28. The method of claim 15 wherein driving the 2-DOF drive-mode oscillator and
- 2 driving 2-DOF sense-mode oscillator comprise driving a mass in a drive direction, and
- 3 sensing motion of a mass in a sense direction, wherein the frequency response of both
- 4 the drive-mode oscillator and sense-mode oscillator have two resonant peaks and a flat
- 5 region between the peaks, operating both the drive-mode oscillator and sense-mode
- 6 oscillator in the flat region of their response curves, and matching the drive anti-
- 7 resonance frequency, ω_{2x} , of the second mass and sense anti-resonance frequency,
- 8 ω_{3y} , of the third mass, namely setting $\omega_{3y} = \omega_{2x}$, or equivalently $(k_{3y}/m_3)^{1/2} = (k_{2x}/(m_2 + m_2)^{1/2})^{1/2}$
- $9 m_3))^{1/2}$ and determining therefrom the optimal system parameters, together with the
- optimized ratios $\mu_x = (m_2 + m_3)/m_1$, $\gamma_x = \omega_{2x}/\omega_{1x}$, $\mu_y = m_3/m_2$, and $\gamma_y = \omega_{3y}/\omega_{2y}$, where k_{3y}
- is the spring constant of the flexures coupled to the third mass, where m₃ is the
- magnitude of the third mass, k_{2x} is the spring constant of the flexures coupled to the

- 13 second mass, m₂ is the magnitude of the second mass, m₃ is the magnitude of the third
- 14 mass, ω_{1x} is the drive anti-resonance frequency of the first mass, and ω_{2y} is the sense
- anti-resonance frequency of the second mass.